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(11) **EP 1 837 911 A3**

EUROPEAN PATENT APPLICATION (12)(88) Date of publication A3: (51) Int Cl.: H01L 27/16^(2006.01) G01J 5/20^(2006.01) 04.05.2011 Bulletin 2011/18 H01L 27/146 (2006.01) (43) Date of publication A2: 26.09.2007 Bulletin 2007/39 (21) Application number: 07110375.8 (22) Date of filing: 09.01.1998 (84) Designated Contracting States: · Ishikawa, Tomohiro DE FR GB c/o MITSUBISHI DENKI KABUSHIKI KAISHA Chiyoda-ku Tokyo 100-8310 (JP) (30) Priority: 27.01.1997 JP 1226997 Tsutsumi, Kazuhiko c/o MITSUBISHI DENKI KABUSHIKI KAISHA (62) Document number(s) of the earlier application(s) in Chiyoda-ku Tokyo 100-8310 (JP) accordance with Art. 76 EPC: Hata, Hisatoshi 98100324.7 / 0 859 413 c/o MITSUBISHI DENKI KABUSHIKI KAISHA Chiyoda-ku Tokyo 100-8310 (JP) (71) Applicant: MITSUBISHI DENKI KABUSHIKI **KAISHA** (74) Representative: TBK-Patent Chiyoda-ku, Tokyo 100-8310 (JP) **Bavariaring 4-6** 80336 München (DE) (72) Inventors: · Kimata, Masafumi c/o MITSUBISHI DENKI KABUSHIKI KAISHA

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(54) Infrared focal plane array

(57) A two-dimensional infrared focal plane array comprising temperature detecting units in which one temperature detecting unit is arranged for each pixel in a twodimensional arrangement on a semiconductor substrate, said temperature detecting unit being formed integrally with a thermal type light detector and a means for detecting a change in characteristic of said thermal type light detector, said change being caused by an incident infrared ray, wherein a temperature detecting portion which is supported by support legs comprising a high thermal resistance material capable of controlling a heat flow to said semiconductor substrate and which has a temperature detecting element, and an infrared ray absorbing portion are provided for each pixel on said semiconductor substrate, characterized in that said infrared ray absorbing portion is spliced by at least one splicing pillar with said temperature detecting portion, and said infrared ray absorbing portion comprises silicon dioxide or silicon nitride, or a laminate film of silicon dioxide and silicon nitride, and wherein the thermal resistance of the splicing pillar is smaller than the thermal resistance of the support legs.





Printed by Jouve, 75001 PARIS (FR)



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